

DOCKET NO: 295715US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

:

MASARU SASAKI, ET AL.

: EXAMINER: MALEK, M.

SERIAL NO: 10/591,343

:

FILED: AUGUST 31, 2006

: GROUP ART UNIT: 2813

FOR: METHOD FOR MANUFACTURING :
SEMICONDUCTOR DEVICE AND
PLASMA OXIDATION METHOD

AMENDMENT AND REQUEST FOR RECONSIDERATION

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Responsive to the Office Action of December 8, 2010, Applicants request reconsideration in view of the following amendment and remarks submitted concurrently with a Terminal Disclaimer.

Remarks begin on page 2 of this paper.